

**Notice of References Cited**

		Application/Control No.	Applicant(s)/Patent Under Reexamination MIZE ET AL.	
		09/595,583	Examiner	Art Unit Yelena G. Gakh, Ph.D. 1743

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,674,926	07-1972	Dewey et al.	348/138
	B	US-5,502,306	03-1996	Meisburger et al.	250/310
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Udler et al. "Tungsten-Titanium Sputtering Target Technology", Advanced Materials Division, Technical Note 203, 1994
	V	http://www.iamaterials.com/sputter/stargets.htm, International Advanced Materials, 1999
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.